

Jefferson Lab PAC 48 Proposal Cover Sheet

Proposal Type: Jeopardy Physics Category3D structure of the hadrons Proposal Title: Run Group H Jeopardy Update Document. CLAS12 Experiments with a TransverselyPolarized Target Experiment Hall: B Days Requested for Approval: 110

Proposal Physic Goals:

Indicate any Experiments that have physics goals similar to those in your proposal. Approved Conditionally approved, and/or Deferred Experiment(s) or proposals.

E12-09-018 E12-10-006 E12-11-108

Collaboration-Approved Proposals:

If you will be running in parallel with an approved experiment, please indicate the experiment number

N/A

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If you will be running in parallel with an approved experiment, please indicate the experiment number

N/A

Contact Person:

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Spokesperson:

- 1. Harut Avakian
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- 5. Keith Griffioen
- 6. Kyungseon Joo
- 7. Michael Lowry
- 8. Marco Mirazita
- 9. Silvia Niccolai
- 10. Marco Radici
- 11. Xiangdong Wei

Lab Resources List

JLab Proposal No. : No Data Date: No Data

List below significant resources - both in equipment and human - that you are requesting from Jefferson Lab in support of mounting and executing the proposed experiment. Do not include item that will be routinely supplied to all running experiments such as the base equipment for the hall and technical support for routine operation, installation, and maintenance.

Major Installations:

Either your equip. or new equip requested from JLab

None beyond standard Hall B and HDice

New Support Structures:

None beyond standard Hall B

Data Aquisition/ Reduction

New Support Structures:

Standard Support. JLab computer farm, Hall B DAQ, MSS for data storage, work disk space forcooking and analysis, standard Hall B online/offine computing, Open Science Grid for simulation

New Software:

Standard Hall B DAQ for online, standard calibration, cooking, and analysis software and support for Hall B data reduction, analysis, and simulation, CLAS12 database.

Major Equipment:

Magnets:

CLAS12 torus and solenoid, standard beamline magnets including the Hall B photon tagger for beam tuning and Moller polarimeter, HDice magnets.

Power Supplies:

Standard supplies for Hall B operation of CLAS12 and beamline elements

Detectors:

CLAS12, MM, CND, RICH, tagger and beamline

Electronics:

Standard for Hall B and CLAS12, including Moller polarimeter

Computer Hardware

Standard for Hall B online, JLab computer farm, MSS, and work disk storage, Open Science Grid

Other:

N/A

Beam Requirements List

JLab Proposal No: No Data Anticipated Run Date: No Data Contact Person: Marco Contalbrigo Email: contalbrigo@fe.infn.it Hall: B

Date: No Data

PAC Approved Days: No Data Phone: +390532974310 Hall Liaison: No Data

List all combinations of anticipated targets and beam considerations required to execute the experiment. (This list will form the primary basis for the Radiation Safety Assessment Document (RSAD) calculations that must be performed for each experiment.)

Beam Energy(MeV)	Mean Beam Current(µA)	Polarization and Other Requiremen ts	Est Beam- On Time(hours)	Target Materials	Target Thickness(mg/cm²)
10.6 GeV	few nA	Beam polarization	110 days	HDice	0.147 g/cm2

The beam energies, EBeam, available are: EBeam = N x ELinac where N = 1, 2, 3, 4, or 5. ELinac = 800 MeV, i.e, available EBeam are 800, 1600, 2400, 3200 and 4000 MeV. Other energies should be arranged with the hall leader before listing.

Check all items for which there is an anticipated need.

Cryogenic	S	Electrical Equipment	Radioactive Materials
Beamli	ne Magnets	Cryo/Electrical Devices	List radioactive or
	sis Magnets	Capacitor Banks	
	get Magnets	High Voltage	
Туре:	N/A	Exposed Equipment	N/A
Flow Rate:	N/A		
Capacity:	N/A		
Pressure Ves		Flammable	Other Target Materials
Inside Diameter:	N/A	Type: N/A	
Operating Pressure:	N/A	Flow Rate: N/A	
Window Material:	N/A	Capacity: N/A	
Window Thickness:	N/A	Drift Container	
Special Target M	atoriala		Tungsten Uranium
Special Target M	Helium	Type: N/A Flow Rate: N/A	
Н	Deuterium		
μ	Deutenum	Capacity: N/A	HD
Vacuum Ves		Radioactive Sources	Large Mech. Structures
Inside Diameter:	N/A	Permanent Installment	Lifting Devices
Inside Diameter: Operating Pressure:	N/A N/A	Permanent Installment Temporary Use	Lifting Devices Motion Controllers
Inside Diameter: Operating Pressure: Window Material:	N/A N/A N/A	Permanent Installment Temporary Use Type: N/A	Lifting Devices Motion Controllers Scaffolding
Inside Diameter: Operating Pressure:	N/A N/A	Permanent Installment Temporary Use	Lifting Devices Motion Controllers Scaffolding
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Inside Diameter: Operating Pressure: Window Material: Window Thickness:	N/A N/A N/A	Permanent Installment Temporary Use Type: N/A Strength: N/A	Lifting Devices Motion Controllers Scaffolding Elevated Platforms General
Inside Diameter: Operating Pressure: Window Material: Window Thickness:	N/A N/A N/A	Permanent Installment Temporary Use Type: N/A Strength: N/A Hazardous Materials Cyanide Plating Materials Scintillation oi	Lifting Devices Motion Controllers Scaffolding Elevated Platforms General Base Equipment Temp. Mod. To Base Equip.
Inside Diameter: Operating Pressure: Window Material: Window Thickness: Lasers	N/A N/A N/A N/A	Permanent Installment Temporary Use Type: N/A Strength: N/A Hazardous Materials Cyanide Plating Materials Scintillation oi PCBs	Lifting Devices Motion Controllers Scaffolding Elevated Platforms General Base Equipment Temp. Mod. To Base Equip. Perm. Mod. to Base Equip.
Inside Diameter: Operating Pressure: Window Material: Window Thickness: Lasers Type: Wattage:	N/A N/A N/A N/A	Permanent Installment Temporary Use Type: N/A Strength: N/A Hazardous Materials Cyanide Plating Materials Scintillation oi PCBs Methane	Lifting Devices Motion Controllers Scaffolding Elevated Platforms Base Equipment Temp. Mod. To Base Equip. Perm. Mod. to Base Equip. Major New Apparatus
Inside Diameter: Operating Pressure: Window Material: Window Thickness: Lasers Type: Wattage:	N/A N/A N/A N/A N/A N/A Permanent Temporary	Permanent Installment Temporary Use Type: N/A Strength: N/A Hazardous Materials Cyanide Plating Materials Scintillation oi PCBs Methane TMAE	Lifting Devices Motion Controllers Scaffolding Elevated Platforms Base Equipment Temp. Mod. To Base Equip. Perm. Mod. to Base Equip. Major New Apparatus Other General:
Inside Diameter: Operating Pressure: Window Material: Window Thickness: Lasers Type: Wattage:	N/A N/A N/A N/A N/A N/A Permanent Temporary Calibration	Permanent Installment Temporary Use Type: N/A Strength: N/A Hazardous Materials Cyanide Plating Materials Scintillation oi PCBs Methane TMAE	Lifting Devices Motion Controllers Scaffolding Elevated Platforms
Inside Diameter: Operating Pressure: Window Material: Window Thickness: Lasers Type: Wattage:	N/A N/A N/A N/A N/A N/A Permanent Temporary	Permanent Installment Temporary Use Type: N/A Strength: N/A Hazardous Materials Cyanide Plating Materials Scintillation oi PCBs Methane TMAE TEA Photographic Developers	Lifting Devices Motion Controllers Scaffolding Elevated Platforms
Inside Diameter: Operating Pressure: Window Material: Window Thickness: Lasers Type: Wattage:	N/A N/A N/A N/A N/A N/A Permanent Temporary Calibration	Permanent Installment Temporary Use Type: N/A Strength: N/A Hazardous Materials Cyanide Plating Materials Scintillation oi PCBs Methane TMAE TEA Photographic Developers Other Hazardous Materials:	Lifting Devices Motion Controllers Scaffolding Elevated Platforms
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Computing Requirements List

Proposal Title: Run Group H Jeopardy Update Document. CLAS12 Experiments with a TransverselyPolarized Target **Contact Person:** Marco Contalbrigo **Experiment Hall:** B

Data

Silo/Mass Storage (Tape): 2100 TB

Amount of Simulated Data Expected (TB): 150 TB

Amount of Raw Data Expected (TB): 1500 TB

Amount of Processed Data Expected: 500 TB

Online Storage (Disk) Required (TB): 210 TB

Imported Data Expected from Offsite Institutions: 150 TB

Exported Data Expected to Offsite Locations: 1300 TB

Computing

Simulation Requirements (SPEC CINT2000 hrs): 22

Production (Replay, Analysis, Cooking) Requirements (SPEC CINT2000 hrs): 20

Other Requirements:

Please add any additional information that will be useful for JLab's Information Technology group regarding unique configurations or that may require additional resources and/or coordination. Please indicate if possible what fraction of these resources will be provided by collaborating institutions and how much is expected to be provided by JLab.

JLab will provide MSS, disk space for data processing/cooking, disk space for DSTs. DSTs will be made available for offsite copying and analysis, Open Science Grid for simulation.

Assumed Resource Requirements:

Use this section to provide any information regarding the assumed requirements for the resources needed.

Standard Hall B requirements